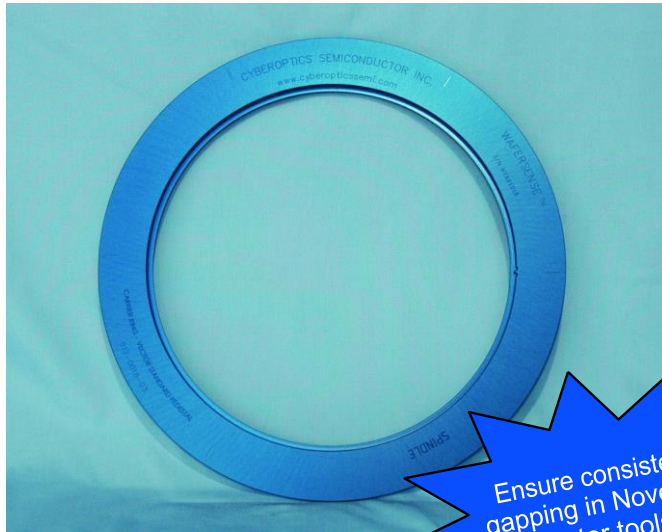
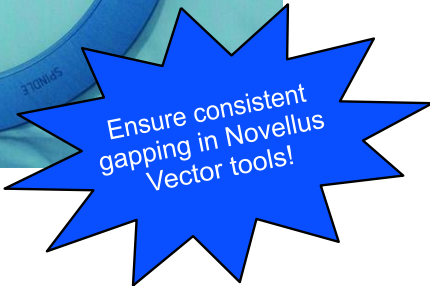




AGS Novellus Adapter Ring (AGS300E1 and AGS300E2)



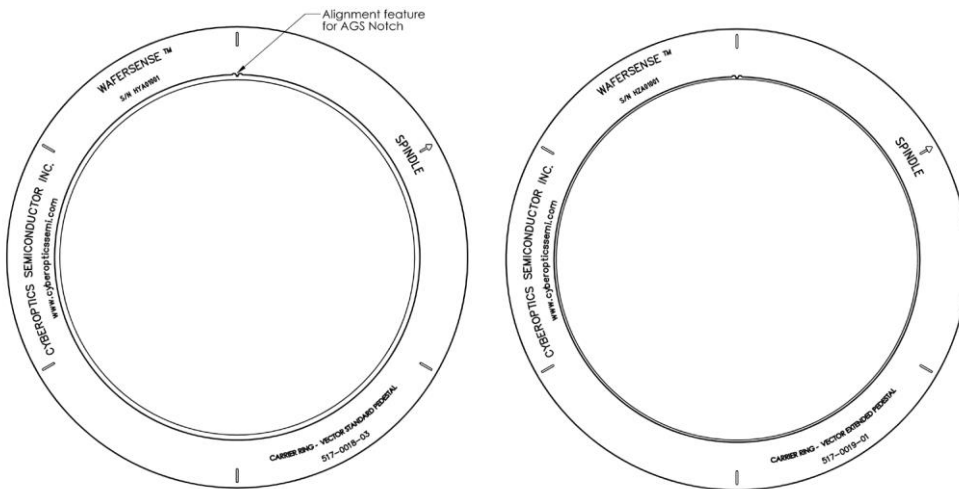
Above: AGS300E1 adapter ring



CyberOptics Semiconductor has developed adapter rings for its WaferSense™ AGS300 for use in Novellus Vector tools. The adapter rings allow automated transport of the AGS300 between pedestals within the vacuum chamber. In addition, they speed process set up and ensure consistent gapping between all four pedestals inside the chamber.



Dimensions (AGS300E1 and AGS300E2)



For additional drawings, please contact tech support at CSsupport@cyberoptics.com.



AGS300 Auto Gapping System
(above)

AGS300E1 (left) is for use with the Standard Pedestal Design

AGS300E2 (right) is for use with the Extended Pedestal Design